

Notice of References Cited	Application/Control No. 10/527,406		Applicant(s)/Patent Under Reexamination TROCZYNSKI ET AL.	
	Examiner DANAH AL-AWADI		Art Unit 1615	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,113,993	09-2000	Gao et al.	427/573
*	B	US-2002/0123801	09-2002	Pacetti et al.	623/1.46
*	C	US-2001/0029351	10-2001	Falotico et al.	604/103.02
*	D	US-5,759,376	06-1998	Teller et al.	205/50
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Choi et al. "Ion-Beam-Assisted Deposition (IBAD) of hydroxyapatite Coating layer on Ti-Based Metal substrate" Biomaterials Volumne 21, Issue 5, March 2000 Pages 469-473.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.